EV205822777 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.	
Filing Date	
Inventorship	
Applicant	Microsoft Corporation
Attorney's Docket No.	MS1-1523US
Title: Stereo-Coupled Face Shape Registration	

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

REMARKS

The citations listed, copies attached, are submitted in compliance with the duty of disclosure defined in 37 CFR §1.56. The Examiner is requested to make these citations of official record in this application.

Respectfully Submitted,

Bradley K. DeSandro Reg. No. 34,521

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		COOTES, T.F., et al., "Active Shape Models - Their Training and Application," Computer Vision and Image Understanding, Vol. 61, No. 1, January 1995, pp. 38-59.	
		S.Z. Li, Q.D. Fu, L. Gu, B. Scholkopf, Y.M. Cheng, H.J. Zhang. "Kernel Machine Based Learning for Multi-View Face Detection and Pose Estimation". In Proceedings of 8th IEEE International Conference on Computer Vision. Vancouver, Canada. July 9-12, 2001.	
		Z. Zhang, Determining the Epipolar Geometry and its Uncertainty: A Review. The International Journal of Computer Vision, 27(2):161-195, 1998.	
		A.P. Pentland, B.Moghaddam, and T.Starner, "View-Based and Modular Eigenspaces for Face Recognition," In the Proceeding of IEEE Computer Society Conference on Computer Vision and Pattern Recognition, pages 8491, 1994.	
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